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Bib Data Sheet

**CONFIRMATION NO. 8933**

| SERIAL NUMBER | FILING OR 371(c) DATE | CLASS | GROUP ART UNIT | ATTORNEY DOCKET NO. |
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| 10/506,534 | 09/03/2004<br>RULE | 438 | 2812 | 061063-0311751 |

**APPLICANTS**

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** CONTINUING DATA **********

This application is a 371 of PCT/JP03/02568 03/05/2003

** FOREIGN APPLICATIONS **********

JAPAN 2002-261286 09/06/2002
JAPAN 2002-059182 03/05/2002

| Foreign Priority claimed | STATE OR COUNTRY | SHEETS DRAWING | TOTAL CLAIMS | INDEPENDENT CLAIMS |
|---|---|---|---|---|
| ☑ yes ☐ no | JAPAN | 8 | 5 | 1 |
| 35 USC 119 (a-d) conditions met: ☑ yes ☐ no ☐ Met after Allowance | | | | |
| Verified and Acknowledged: Examiner's Signature / Initials | | | | |

**ADDRESS**

00909

**TITLE**

Process for producing silicon single crystal layer and silicon single crystal layer

| FILING FEE RECEIVED | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | ☐ All Fees<br>☐ 1.16 Fees ( Filing )<br>☐ 1.17 Fees ( Processing Ext. of time )<br>☐ 1.18 Fees ( Issue )<br>☐ Other _____<br>☐ Credit |
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